Under the Paperwork Reduction Act of 1995, no perso			PTO/SB/08a (05-07) Approved for use through 09/30/2007. OMB 0851-0031 d Trademark Office; U.S. DEPARTMENT OF COMMERCE information unless it contains a valid OMB control number.		
	Application Number Filing Date		09763641 2001-02-26		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)					
	First Named Inventor Kathrine Giles et al.		ine Giles et al.		
	Art Unit		2812		
(Not for Submission under 37 GFK 1.33)	Examiner Name	Ghyka	a, Alexander G		
	Attorney Docket Numb	er	WLJ.0072		

				٠.	U.S.I	PATENTS			Remove	
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date		Name of Patentee or Applicant of cited Document		Pages,Columns,Lines where Relevant Passages or Releva Figures Appear		
	1					† !				
If you wish	n to a	l dd additional U.S. Pate	nt citatio	l n inform	ation pl	ease click the	Add button.		Add	
			U.S.P	ATENT	APPLIC	CATION PUB	LICATIONS	•	Remove	
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publica Date	ition	Name of Pat of cited Docu	entee or Applicant ument	Releva	Columns Lines on I ant Passages or I s Appear	
	1 to ac	dd additional U.S. Publ				n information		d button	Add	
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ²	/ ·	Kind Code4	Publication	Name of Patente Applicant of cited Document	e or	Pages,Columns,I where Relevant Passages or Rele Figures Appear	
AC	1	10-310866	JP			1998-11-24	SHINETSU CHEMICAL			×
	_					1997-09-09	TOSHIBA			

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Not for submission under 37 CFR 1.99)

Application Number		09763641			
Filing Date		2001-02-26			
First Named Inventor K		ine Giles et al.			
Art Unit		2812			
Examiner Name	Ghyka	a, Alexander G			
Attorney Docket Number		WLJ.0072			

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T5
Ac	1	Akiro NARA et al., "Low Dielectric Constant Insulator Formed by Downstream Plasma CVD at Room Temperature Using TMS/O2", Jpn. J. Appl. Phys. Vol. 36 (1997) Pt. 1, No. 3B, pages 1477-1480.	×
If you wis	h to a	dd additional non-patent literature document citation information please click the Add button Add	-
		EXAMINER SIGNATURE	
Examiner	Signa	eture Date Considered 8/26/04	
*EXAMIN citation if	ER: Ir not in	itial if reference considered, whether or rot citation is in conformance with MPEP 609. Draw line through a conformance and not considered. Include copy of this form with next communication to applicant.	
Standard S ⁻ 4 Kind of do	T.3). ³ f cument	of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WFor Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark anslation is attached.	zument.